

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/630,915	KUECHLER, GUNTER	
Examiner	Art Unit	
Edna Wong	1795	

SEARCHED					
Class	Subclass	Date	Examiner		
136	243-291	2/7/2007	ADF		
-			_		
			_		
			.,		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
		, · · · · · · · · · · · · · · · · · · ·			
	L				
1					

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
See EAST Search History	2/7/2007	ADF		
Inventor Search	2/7/2007	ADF		
Consulted with Nam Nguyen	2/7/2007	ADF		
Search Updated	10/13/2007	EW		
EAST	10/13/2007	EW		
Search Updated	1/25/2008	EW		